

PTO-1449 (Modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT	ATTY. DOCKET NO. 03848.80505	SERIAL NUMBER 09/318,775
	APPLICANT Calvin F. Quate, et al.	
	FILING DATE 5/26/99	GROUP ART UNIT 2873

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09/318775
05/26/99

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	Calvin F. Quate, et al.	
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